Minigaps in strained silicon quantum wells on tilted substrates

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The two-dimensional electron gas formed at the inverted surface of a tilted silicon substrate shows unusual magnetotransport properties due to the presence of a minigap in the density of states. For metal–oxide–semiconductor inversion layers the strong scattering at the interface limits the mobility to values \( \mu < 10^{-20000} \text{ cm}^2/\text{V s} \). To achieve mobilities approaching \( 10^5 \text{ cm}^2/\text{V s} \) we have used strained Si:SiGe quantum wells grown on substrates tilted away from the (001) normal by 0°, 2°, 4°, 6°, and 10°. Their transport properties have been measured in the temperature range of 20–500 mK. All the samples show strong Shubnikov–de Haas oscillations. For the 2° and 4° samples the envelope of the fast oscillations is modulated by a longer period oscillation at low magnetic fields. We attribute the slow oscillation in the 2° and 4° samples to the presence of a minigap. For the 6° and 10° samples the minigap is higher than the Fermi energy and is not expected to influence the transport properties. © 1999 American Vacuum Society.

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I. INTRODUCTION

Tilted substrates have been used to explore a number of issues related to semiconductor interfaces. Vicinal GaAs substrates, i.e., those tilted a few degrees from high symmetry planes such as the (001) and (111) have been used to study the growth of quantum wires and lateral surface superlattices and for investigating dopant incorporation. Vicinal silicon substrates have an even longer history, having been used in the early years of metal–oxide–semiconductor (MOS) technology to find Si:SiO₂ interfaces with the lowest interface state density. Silicon wafers with high index surfaces such as (11n) are readily available and correspond to offcut angles of a few degrees between the surface normal and the [001] direction. Surprisingly, silicon MOS inversion layers on (115) and (118) substrates have shown curious transport anomalies, which were later explained by the formation of a minigap in the density of states. Recently, Si:SiGe quantum wells on tilted substrates have been used to reduce the density of threading dislocations present in these strained layers as well as to explore the nucleation of dislocations via the modified Frank–Read mechanism. Strained silicon quantum wells on tilted substrates also show interesting surface morphology as well as anisotropic transport properties. In this article we describe recent transport measurements of modulation doped Si:SiGe quantum wells on various offcut substrates at temperatures down to 20 mK. The results are consistent with the formation of a minigap in the density of states. We begin with a discussion of the layer structure and surface morphology of these layers.

II. LAYER STRUCTURE AND SURFACE MORPHOLOGY

The strained silicon quantum wells used in this work all had similar layer structures (see Fig. 1) and were grown by gas source molecular beam epitaxy (MBE), the details of which have been presented elsewhere. Approximately 1% tensile strain is required in the silicon channel to produce the necessary conduction band offset. This can be achieved by growing a thin silicon layer on a relaxed SiGe substrate with a germanium concentration in the range of 20%–30%. In our case the germanium concentration in the buffer layer is increased linearly from 0% to 29% over a thickness of 2 μm and is followed by 1 μm of Si₀.₇₂Ge₀.₂₈. The 100 Å thick quantum well is modulation doped, i.e., it is separated from 500 Å of heavily doped Si₀.₇₂Ge₀.₂₈ by a 150 Å spacer layer with the same alloy concentration. The layers are capped with 50 Å of silicon.

During growth of the graded buffer layer, threading dislocations nucleate and are free to glide on the four equivalent {111} planes producing strain relieving misfit segments (60° dislocations). Surface steps due to the 60° misfit dislocations and reduced growth rates near to them lead to the well known “cross-hatch” pattern on the sample surface. The {111} glide planes intersect the surface of standard (001) substrates along (110) directions and the cross hatching is orthogonal. However, on tilted substrates such as (11n) the situation is different. Two of the {111} planes still intersect the surface along [110]. The other two planes align at a small angle \( \alpha/2 \) on either side of [110], given by

\[
\cos \alpha = \frac{2 \cos^2 \phi + \sin^2 \phi}{2 \cos^2 \phi + 3 \sin^2 \phi},
\]

where \( \phi = \arccos(n/(n^2 + 1)) \) is the offcut angle between the surface normal and the [001]. The different surface morphologies for an on-axis and a 6° off-axis sample are shown in Fig. 2 and measurements of \( \alpha \) for different values of \( \phi \) confirm the relationship in Eq. (1).

The surface roughness of the cross hatching shown in Fig. 2 has a typical correlation length of 5–10 μm with a root mean square (rms) amplitude of \( \sim 10 \) nm for the on-axis
sample, decreasing to ~5 nm for the higher off-cut angle samples. Despite the fact that the surface roughness is comparable to the thickness of the quantum well it does not seem to unduly influence the electron mobility, with values as high as 95 000 cm²/V s being obtained for the quantum wells grown on (001) substrates. However, as the tilt angle is increased, additional surface features with a much smaller length scale develop due to the formation of terraces on the (11n) surface. In Fig. 3 an atomic force microscopy (AFM) image of the 6° sample shows the terraces running along the [110] direction. The surface of Si(11n) substrates consists of single and double steps and assuming an even mixture the average terrace height and width can be calculated. For a 6° off-cut substrate the average terrace width would be ~2 nm. In fact, the average terrace width and height in Fig. 3 is 17 and 2 nm, respectively, suggesting that considerable step bunching has occurred.

III. ELECTRON TRANSPORT ON TILTED SUBSTRATES

The presence of the terraces leads to anisotropic transport properties for the quantum wells grown on tilted substrates. For transport perpendicular to the step edges extra electron scattering reduces the mobility compared to values measured parallel to the terraces. Figure 4 shows the sheet resistance as a function of magnetic field for a 10° off-cut sample at a temperature of 0.4 K. The samples have standard Hall bar geometries aligned parallel and perpendicular to the step edges. the Shubnikov–de Haas (SdH) oscillations arise from Landau quantization of the density of states as a result of the large magnetic field. They have the same periodicity in each case confirming that the measured sheet density is the same. The higher resistance measured with a current flowing perpendicular to the terraces confirms the lower mobility of this orientation. The mobility measurements are summarized in Table I. The results show a general trend towards increasing anisotropy in the mobility for increasing off-cut angle.

When cooled to lower temperatures the amplitude of the SdH oscillations increases as expected from the reduction in thermal broadening. The 2° and 4° samples, however, show an additional slow oscillation at low fields. The amplitude of the new oscillation is small and easily obscured by the background magnetoresistance and the much larger amplitude of the fast oscillations. In Fig. 5 we show the low field SdH
oscillations of the 0°, 2°, 4°, and 6° samples after subtraction of a quadratic term describing the background magnetoresistance. For a uniform two-dimensional electron gas (2DEG) with a sheet density \( N \), the oscillations have a periodicity that is given by \( \frac{1}{B} = \frac{4e}{N_s \hbar} \) and another of twice the frequency if the field is large enough that the spin splitting can be resolved. The data in Fig. 5 are plotted against inverse magnetic field to highlight the \( 1/B \) periodicity. The slow oscillation is weaker in the 2° sample than in the 4° sample and is not present at all in the 6°, 10°, and on-axis samples. The Fourier transforms of the data from the 0°, 2°, and 4° samples plotted against sheet density are shown in Fig. 6. All of the fast Fourier transform (FFT) spectra have a distinct peak corresponding to sheet densities of 6.9, 9.7, and \( 7.4 \times 10^{11} \text{ cm}^{-2} \) for the 0°, 2°, and 4° samples, respectively. However, only the 2° and 4° samples have a distinct peak at frequencies corresponding to lower electron concentrations. This additional peak is due to the slow oscillation present in the data of Figs. 5(b) and 5(c).

Results similar to those in Figs. 5 and 6 have been reported for silicon MOS inversion layers on 1.2° and 10° off-cut substrates. In both these cases a slow oscillation evolved into a faster oscillation with increasing magnetic field and the results were interpreted in terms of the so-called valley projection model (VPM) which predicts the existence of a minigap in the density of states. For a 2DEG on a (001) substrate there are two low energy valleys in the \( E-k \) dispersion with minima at \((0, 0, \pm k_0)\) where \( k_0 = 0.85(2\pi/a) \), \( a \) being the lattice constant, which is 5.43 Å for silicon. When projected onto the (001) surface the two valleys are coincident and the valley degeneracy is 2. However, when projected onto a low angle vicinal substrate such as (11n) the valleys no longer coincide but cross at points given by \( k = 0.15k_0 \sin \varphi \) where \( \varphi \) is the off-cut angle. The degeneracy is lifted at the crossing points due to valley–valley interactions and a minigap is formed. The width of the minigap increases with the sheet density and off-cut angle and is typically a few meV for densities of a few \( 10^{12} \text{ cm}^{-2} \).

Figure 7 illustrates the occupation of the conduction band in the 2°, 4°, and 6° samples and can be used to explain the results of Fig. 5. For both the 2° and 4° samples the minigap is located below the Fermi energy, \( E_F \). The lower band is completely full and for small magnetic fields only the upper band contributes to the SdH oscillations with a periodicity corresponding to a sheet density \( N_{\text{slow}} \), i.e., the slow oscillations observed in the 2° and 4° samples. As the magnetic field increases, tunneling can occur through the minigap and for fields such that \( E_g = \hbar \omega_c \), magnetic breakdown occurs and the minigap cannot be resolved. At this point the SdH oscillations are faster with a periodicity corresponding to a sheet density \( N_{\text{last}} \). The situation for the 4° sample is similar except now the minigap is higher in energy, because of the larger tilt angle, and the Fermi energy in this sample is smaller. For the 6° sample the minigap is higher than the Fermi energy and only the faster oscillations are observed. Although this argument explains the qualitative behavior we observe, the position of the minigap is not in quantitative agreement.

### Table I. Electron mobilities and sheet densities of the samples used in this work.

<table>
<thead>
<tr>
<th>Off-cut angle (deg)</th>
<th>Electron mobility (cm²/V s)</th>
<th>Sheet density ( (10^{11} \text{ cm}^{-2}) )</th>
</tr>
</thead>
<tbody>
<tr>
<td>0</td>
<td>95 000 95 000</td>
<td>6.9</td>
</tr>
<tr>
<td>2</td>
<td>69 400 69 800</td>
<td>9.7</td>
</tr>
<tr>
<td>4</td>
<td>45 200 35 300</td>
<td>7.4</td>
</tr>
<tr>
<td>6</td>
<td>43 300 40 000</td>
<td>7.1</td>
</tr>
<tr>
<td>10</td>
<td>62 600 14 200</td>
<td>10.5</td>
</tr>
</tbody>
</table>
IV. CONCLUSION

We have measured the transport properties of strained silicon quantum wells on substrates tilted away from the (001) normal by 0°, 2°, 4°, 6°, and 10°. All the layers show cross hatching with a characteristic length scale of 10 µm while the tilted substrates show terracing with much smaller characteristic length scales. The extra scattering induced by the terraces leads to anisotropic electron mobility when measured parallel and perpendicular to the step edges. At the lowest temperatures an additional slow oscillation is seen in the magnetoresistance of the 2° and 4° samples that we attribute to the presence of a minigap.

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